

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kimitaka MURASHITA

Serial No. 10/028,264

Group Art Unit: 2862

Confirmation No. 2737

Filed: December 28, 2001

Examiner: Scott A. Rogers

For: DISPLAY MEASURING METHOD AND PROFILE GENERATING METHOD

COMMUNICATION TO THE EXAMINER

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The present application claims priority to Japanese Patent Application No. PCT/JP99/04588 filed on August 25, 1999. A submission of certified copy of prior foreign applications was filed on August 25, 1999. A copy is enclosed.

This application was allowed on May 4, 2007. The Examiner is requested to acknowledge the claim for priority and receipt of the priority documents, substantially prior to the Issue Fee due date of August 6, 2007. Since this application has been allowed, this matter is somewhat urgent.

Respectfully submitted,

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Date: July 12, 2007

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